

L Number	Hits	Search Text	DB	Time stamp
17	61	(field adj emitter) and (magnet\$4 same lens)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/06 20:58
15	70	250/49\$ and (field adj emitter)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/06 20:58
6	405	315/309	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/06 20:58
7	226	315/336	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/06 20:58
8	61	315/351	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/06 20:58
9	2632	445/24	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/06 20:59
10	1017	445/50	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/06 20:59
11	1719	250/398	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/06 21:00
12	491	250/423F	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/06 21:00
13	353	250/423	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/06 21:00
14	2606	iwamatsu.in.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/06 21:01
16	31	5548181.URPN.	USPAT	2004/01/06 21:01
18	31	250/49\$ and (field adj emitter) and (magnet\$4 same lens)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/06 21:01
19	22	(field adj emitter) and (wafer same (conductive adj layer))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/06 21:01

20	4	(field adj emitter) and (wafer same (conductive adj layer)) and lithograph\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/06 21:01
21	147	"4857161"	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/06 21:01
30	2144	substrate same (conductive adj layer) same (resist)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/06 21:01
33	69	(substrate same (conductive adj layer) same (resist)) and (field adj emission)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/06 21:01